



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Michael Weber-Grabau et al.

Appln. No.: 09/927,102

Filed: August 10, 2001

For: OPTICAL CRITICAL  
DIMENSION METROLOGY  
SYSTEM INTEGRATED INTO  
SEMICONDUCTOR WAFER  
PROCESS TOOL

Confirmation No.: 3815

Group Art: 2877

Examiner: Richard A. Rosenberger

**REVOCATION OF PRIOR POWERS  
AND APPOINTMENT OF NEW  
COUNSEL BY ASSIGNEE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

TOKYO ELECTRON LIMITED, assignee of the entire right title and interest in the above-identified application by assignment dated September 27, 2005, which assignment was recorded in the Patent and Trademark Office on October 7, 2005, at Reel 16851, frame 953, hereby revokes all prior powers of attorney and appoints the practitioners associated with the Customer Number below as attorney(s) and/or agent(s) to prosecute this application and transact all business in the Patent and Trademark Office connected herewith:

**CUSTOMER NO.: 28584**

Please direct all correspondence regarding this application to the following:

STALLMAN & POLLOCK LLP  
Attn: Michael A. Stallman  
353 Sacramento Street, Suite 2200  
San Francisco, CA 94111

Telephone: (415) 772-4900  
Facsimile: (415) 398-2890

Dated: January 10, 2006

TOKYO ELECTRON LIMITED

By: [Signature]  
Name: Hiroshi Ishida  
Title: Vice President IP Department